Docket No.

FILED:

FOR:

213672US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kenji YAMAGUCHI, et al.

SERIAL NO: **NEW APPLICATION**

HEREWITH

EXAMINER: SEMICONDUCTOR DEVICE EVALUATION METHOD AND APPARATUS, SEMICONDUCTOR DEVICE

MANUFACTURING CONTROL METHOD, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND

GAU:

RECORDING MEDIUM

INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 CFR 1.97

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- □ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland Registration Number 21,124



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LIST OF RELATED CASES

Docket Number	Serial or Patent No.	Filing or Issue Date	Status or Patentee
0057-2406-2YYX	09/238,887	01/28/99	PENDING
0057-2577-2YY	09/487,826	01/20/00	PENDING

DOCKET NO.: 213672US2

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kenji YAMAGUCHI, et al.

SERIAL NO.: New Application

FILED: Herewith

FOR: SEMICONDUCTOR DEVICE EVALUATION METHOD AND APPARATUS, SEMICONDUCTOR DEVICE MANUFACTURING CONTROL METHOD, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND RECORDING MEDIUM

STATEMENT OF RELEVANCY

Reference AO on Form PTO-1449:

According to the present invention, insulating gate field effect transistors Tr1-Tr6 have a common gate electrode pattern 1, as shown in Fig. 1. The insulating gate field effect transistors Tr1-Tr6 comprise gate electrodes 1a-1f with different design gate lengths, and sources 2 and drains 3, respectively. Each conductance of gate electrodes of transistors Tr1-Tr6 is measured, and a sheet resistance is calculated based on the inclination of a straight line of a region wherein there is a linear relationship between the measured conductance and the design gate lengths of transistors Tr1-Tr6. Further, based on the sheet resistance, a plurality of intervals between terminals and gate electrode conductance, a gate length that is the width of the gate electrode pattern 1 is calculated.

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE ATTY DOCKET NO. 213672US2					SERIAL NO. NEW APPLICATION			
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Kenji YAMAGUCHI, et al.				30 Td		
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		OTHER REF	ERENCES (ncluding Autho	r, Title, Date, Pertin	ent Pages, e	tc.)			
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